## PATENT APPLICATION

PATENT AP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Application of:		I hereby certify that this paper is being deposited with th	
Applicant(s):	Hotta et al.	United States Postal Service as FIRST-CLASS mail in a envelope addressed to: Mail Stop RCE, Commissioner fo Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.  June 3, 2005 Date  Attorney for Applicant(s) Registration No. 47,954	
Serial No.:	10/612,385		
Conf. No.:	3186		
Filed:	July 2, 2003		
METHO SAME,	TILM TRANSISTOR DEVICE, DD OF MANUFACTURING THE AND THIN FILMTRANSISTOR RATE AND DISPLAY HAVING	THE ) TOR )	
Art Unit:	2811	, ) >	
Examiner:	Hu, Shouxiang	) )	

## $\underline{\mathbf{AMENDMENT}\;\mathbf{D}}$

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-150

Dear Sir:

In response to the final Office Action mailed March 3, 2005, and pursuant to the Request for Continued Examination filed concurrently herewith, please amend the above-identified Application as follows: